Speaker of Session 04

BEYOND LITHIUM ION BATTERY

Miia Mäntymäki received her MSc in inorganic chemistry in 2010 from the University of Helsinki, Finland. During her years as an undergraduate student, she worked with synthesizing precursor molecules for atomic layer deposition (ALD) and studied new hafnium oxide and zirconium oxide ALD processes. Currently Miia is pursuing her PhD at the Laboratory of Inorganic Chemistry at the University of Helsinki under professors Mikko Ritala and Markku Leskelä. Her research is focused on the atomic layer deposition of lithium-ion battery materials and lithium containing thin films in general.

In addition to her research pursuits, Miia has also been active in teaching undergraduate chemistry courses. She is also a member of the team of chemists responsible for training Finnish high school students for the International Chemistry Olympiad (IChO).

Publications in Peer Reviewed Journals:

Atomic Layer Deposition of AlF_3 Thin Films Using Halide Precursors
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Atomic Layer Deposition of LiF Thin Films from Lithd, $Mg(thd)_2$, and TiF_4 Precursors
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Atomic Layer Deposition of LiF Thin Films from Lithd and TiF_4 Precursors
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